



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	BRUCE <i>et al.</i>	Examiner:	Turner, S.
Serial No.:	09/386,112	Group Art Unit:	2877
Filed:	August 30, 1999	Docket No.:	AMDA.261PA (TT2335)
Title:	DUAL-DIFFERENTIAL INTERFEROMETRY FOR SILICON DEVICE DAMAGE DETECTION		

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 9, 2005.

By:

Kelly S. Wathen
Kelly S. Wathen

AMENDMENT AFTER ALLOWANCE UNDER 37 C.F.R. § 1.312

MAIL STOP ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Notice of Allowance, dated May 26, 2005, please amend the application as follows: